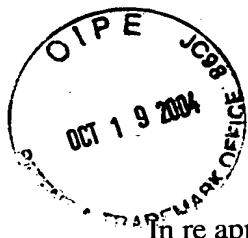


IFW



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q78931

Hideaki ITO, et al.

Appln. No.: 10/736,588

Group Art Unit: 1756

Confirmation No.: 5729

Examiner: John A. McPherson

Filed: December 17, 2003

For: PHOTSENSITIVE TRANSFER MATERIAL COMPRISING THERMOPLASTIC  
RESIN LAYER AND INTERMEDIATE LAYER EACH HAVING SPECIFIED  
SURFACE POTENTIAL, AND METHOD FOR PRODUCING COLOR FILTER

**SUPPLEMENTAL RESPONSE**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In supplement to the Request for Reconsideration filed September 28, 2004,  
Applicants submit herewith a supplemental executed Rule 132 Declaration corresponding to  
the Rule 132 Declaration filed September 28, 2004 except for also including a statement  
under 18 U.S.C. 1001.

In view of the above, reconsideration and allowance of this application are now  
believed to be in order, and such actions are hereby solicited. If any points remain in issue  
which the Examiner feels may be best resolved through a personal or telephone interview, the  
Examiner is kindly requested to contact the undersigned at the telephone number listed  
below.

The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,



Bruce E. Kramer  
Registration No. 33,725

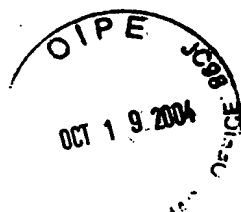
SUGHRUE MION, PLLC  
Telephone: (202) 293-7060  
Facsimile: (202) 293-7860

WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Date: October 19, 2004



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Hideaki ITO, et al.

Attorney Docket No. Q78931

Appln. No.: 10/736,588

Confirmation No.: 5729

Group Art Unit: 1756

Filed: December 17, 2003

Examiner: John A. McPherson

For: PHOTSENSITIVE TRANSFER MATERIAL COMPRISING  
THERMOPLASTIC RESIN LAYER AND INTERMEDIATE LAYER EACH  
HAVING SPECIFIED SURFACE POTENTIAL, AND METHOD FOR  
PRODUCING COLOR FILTER

***DECLARATION UNDER 37 C.F.R. § 1.132***

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

I, Hideaki Ito, hereby declare and state:

THAT I am a citizen of Japan;

THAT I graduated from Graduate School of Science and Engineering,  
Tokyo Institute of Technology, Department of Chemistry in March,  
1990.

THAT I joined Fuji Photo Film Co., Ltd., in 1990, and since then I  
have been engaged in development of a color filter for a liquid crystal  
display.

THAT I am an inventor of the invention described and claimed in the  
above-identified application;

THAT I am familiar with the prosecution of the above-identified  
application; and

THAT the experimentation set forth below was conducted by me or  
under my direct supervision.

EXPERIMENTATION

The closest specific embodiment disclosed in US 5,292,613, namely, sample (a) of Example 11 in the patent was tested. An absolute value of a surface potential of a separated thermoplastic resin layer of the sample was measured under the condition described in the present specification (at a separation speed of 1 m/min. under an atmosphere of 25°C and 30 % RH). The surface potential was 7.3 kV.

The sample does not satisfy the claimed absolute value of a surface potential. This result shows that US '613 does not inherently disclose the presently claimed invention.

A conductive layer is provided only one side of a temporary support in US '613, and a reduction of electrostatic charge caused by separation is not enough. In order to avoid the electrostatic charge by separation, it is important to provide conductivity to a material on a substrate side.

I declare further that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

Date: Oct. 1, 2004

Hideaki Ito  
Hideaki Ito